



**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 3742**

LD  
2-26-03  
AF  
19/D  
( )

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Yasutaka ITO

Group Art Unit: 3742

Application No.: 09/917,749

Examiner: J. Jeffery

Filed: July 31, 2001

Docket No.: 110575.01

For: CERAMIC HEATER WITH OFFSET ELECTRIC HEATING ELEMENTS IN THE  
THICKNESS DIRECTION

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

**RECEIVED**

FEB 25 2003

Sir:

TECHNOLOGY CENTER R3700

In reply to the October 18, 2002 Office Action<sup>1</sup>, please amend the above-identified  
application as follows:

**IN THE DRAWINGS:**

Please amend Figures 1-3, 5, 7-11 and 13 as set forth in the attached Request for  
Approval of Drawing Corrections.

**IN THE SPECIFICATION:**

Page 9, lines 4-25, delete current paragraph and insert therefor:

The ceramic substrate, which constitutes the primary element of the ceramic substrate  
in accordance with the present invention, may be preferably made by using a sintered

<sup>1</sup> The U.S. Patent and Trademark Office was closed on February 18, thus the one-month extension due date is automatically extended to February 19.